# **QNP<sub>HD</sub> Series**

# Single-Axis, High-Dynamic Piezo Nanopositioning Stages

Closed-loop travels from 10 µm to 40 µm

**Direct-drive actuation enables fast response** times and higher-throughput processes

High-precision, frictionless flexure guidance

Long device lifetime

**Superior positioning resolution and linearity** with direct-metrology capacitive sensor option

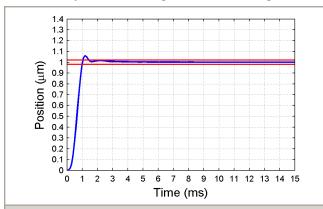
Open-loop and vacuum versions

Aerotech's QNP<sub>HD</sub> piezo nanopositioning stages provide the benefits of both a stage and actuator in one compact, high-stiffness package. With a direct-metrology, capacitive sensor feedback option, high resonant frequencies and high load capacity, the QNP<sub>HD</sub> is ideal for a wide range of highspeed and high-precision applications such as scanning probe microscopy, disc-drive testing, or semiconductor wafer articulation.

## Fast Response with Exacting Precision

The QNP<sub>HD</sub> employs a direct-drive actuation design and an optimized structure enabling millisecond-level response and move-and-settle times.

Guided by precision flexures that are optimized using finite element analysis to ensure high-stiffness and long device



QNPHD30L-25-C move-and-settle plot for a 1 µm step, 200 gram payload and a settle window of  $\pm$  20 nm. All QNP<sub>HD</sub> exhibit excellent dynamic performance enabling higherthroughput processes.



life, the QNP<sub>HD</sub> provides high-dynamics while maintaing excellent geometric performance (straightness and angular errors) for critical nanopositioning applications.

## High-Resolution and Positioning Accuracy

The QNP<sub>HD</sub> has the option of closed-loop feedback (-C) using a unique capacitive sensor design that allows for subnanometer resolution and single-digit nanometer linearity errors. The capacitive sensors measure the output of the positioning carriage directly enabling superior accuracy and repeatability.

#### **Ultra-Precision Control**

When coupled with Aerotech's Q-series controllers and drives, the QNP<sub>HD</sub> demonstrates sub-nanometer positioning resolution and high-positioning bandwidth. Software options such as Aerotech's Dynamic Controls Toolbox and Motion Designer packages provide a host of advanced yet easy-to-use tools such as Learning Control, Harmonic Cancellation, and Command Shaping, providing improved tracking errors and faster step-and-settle times.

Automatic parameter and calibration identification is accomplished using Aerotech's FlashConfig feature. The stage is automatically identified and all operational parameters including axis calibration data are uploaded into the controller ensuring safe, accurate and true "plug-andplay" operation.

#### **Mounting Flexibility**

The QNP<sub>HD</sub> is available with rear and side cable exit options along with mounting features for both horizontal and vertical orientations. This flexibility allows the user to orient and package the stage for the most optimal arrangement without designing various adapter plates and brackets that increase size and design complexity.

An optional mounting plate provides direct mounting to English or metric optical breadboard tables. Custom designs and vacuum-prepared versions are available upon request.

# ${\rm QNP_{HD}\ Series\ SPECIFICATIONS}$

Mechanical Specifications		QNP <sub>HD</sub> 30L-25	QNP <sub>HD</sub> 30L-40
Closed-Loop Travel		25 μm	40 μm
Open-Loop Travel, -30 to +150 V(1)		32 μm	50 μm
Closed-Loop	0.05 nm	0.10 nm	0.10 nm
Open-Loop	0.02 nm	0.03 nm	0.05 nm
Linearity <sup>(3,4)</sup>		0.02%	0.02%
Bidirectional Repeatability <sup>(5)</sup>		1 nm	2 nm
Pitch/Yaw		5 μrad (1.0 arc sec)	7.5 µrad (1.5 arc sec)
Stiffness (in direction of motion) <sup>(6)</sup>		31 N/µm	29 N/μm
Unloaded Resonant Frequency <sup>(6)</sup>		4100 Hz	3500 Hz
Resonant Frequency (200 g load) <sup>(6)</sup>		1900 Hz	1700 Hz
Horizontal	2 kg	2 kg	2 kg
Vertical	7 kg	10 kg	10 kg
Maximum Acceleration (Unloaded)(8)		1250 m/s <sup>2</sup>	750 m/s <sup>2</sup>
Moving Mass (Unloaded)		54 g	77 g
Stage Mass		0.15 kg	0.20 kg
terial Stainless Steel		•	
ne Between Failure) 30,000 Hours			
	O V <sup>(1)</sup> Closed-Loop Open-Loop  ion) <sup>(6)</sup> cy <sup>(6)</sup> oad) <sup>(6)</sup> Horizontal Vertical aded) <sup>(8)</sup>	10 μm 10 μm 10 V(1) 12 μm Closed-Loop 0.05 nm 0 pen-Loop 0.02 m 0.02% 1 nm 5 μrad (1.0 arc sec) ion)(6) 60 N/μm cy(6) 7000 Hz oad)(6) 2500 Hz Horizontal 2 kg Vertical 7 kg aded)(8) 2250 m/s² 39 g 0.11 kg	10 μm 25 μm  0 V(1) 12 μm 32 μm  Closed-Loop 0.05 nm 0.10 nm  Open-Loop 0.02 nm 0.03 nm  0.02% 0.02%  1 nm 1 nm  5 μrad (1.0 arc sec) 5 μrad (1.0 arc sec)  ion)(6) 60 N/μm 31 N/μm  cy(6) 7000 Hz 4100 Hz  oad)(6) 2500 Hz 1900 Hz  Horizontal 2 kg 2 kg  Vertical 7 kg 10 kg  aded)(8) 2250 m/s² 1250 m/s²  39 g 54 g  0.11 kg 0.15 kg  Stainless Steel

#### Notes:

- 1. Value ±10%
  2. See Piezo Engineering reference section 4.2 for description of resolution.
  3. Certified with each stage (closed-loop feedback models only).
- 4. Measured approximately 15 mm above the carriage by an external metrology device. See Piezo Engineering reference section 4.1 for description of linearity specifications. 5. Specified as a 1 sigma (standard deviation) value. See Piezo Engineering reference section 4.3 for description of bidirectional repeatability. 6. Values ±20%.

- 7. On-axis loading listed.
- 8. Requires the selection of an appropriate amplifier to achieve the listed values.

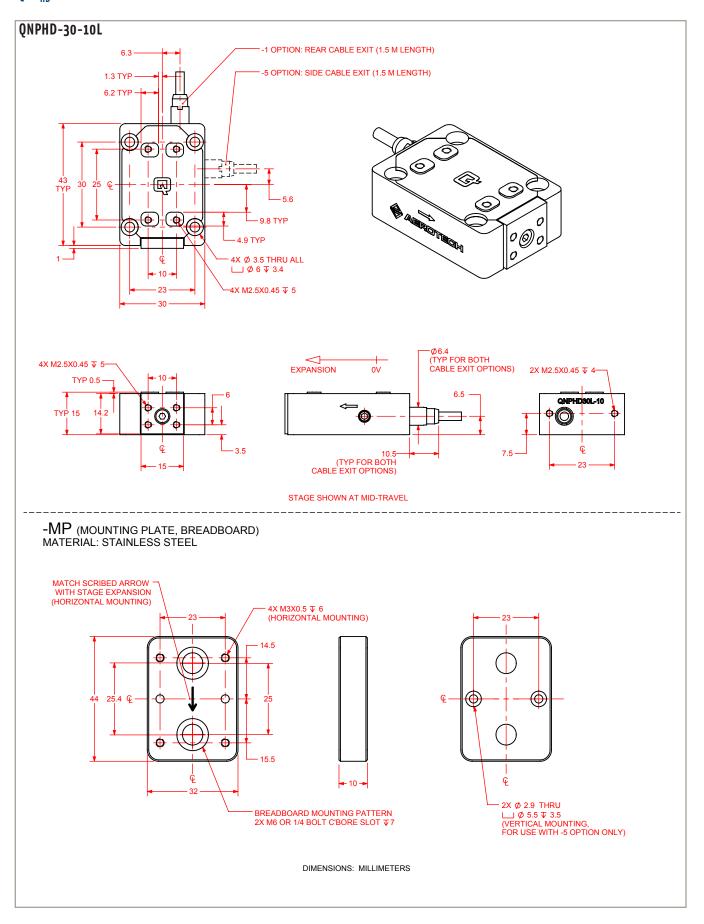
Electrical Specifications	QNP <sub>HD</sub> 30L-10	QNP <sub>HD</sub> 30L-25	QNP <sub>HD</sub> 30L-40
Drive System	Piezo Multi-Layer Stack Actuator		
Feedback	Closed-loop: Integrated Capacitive Sensor (-C) Open-loop: None (-)		
Max Voltage	-30 V to +150 V		
Piezo Stack Capacitance(1)         0.7 μF         2.3 μF         3.4 μF		3.4 µF	

<sup>1.</sup> Value ±20%.

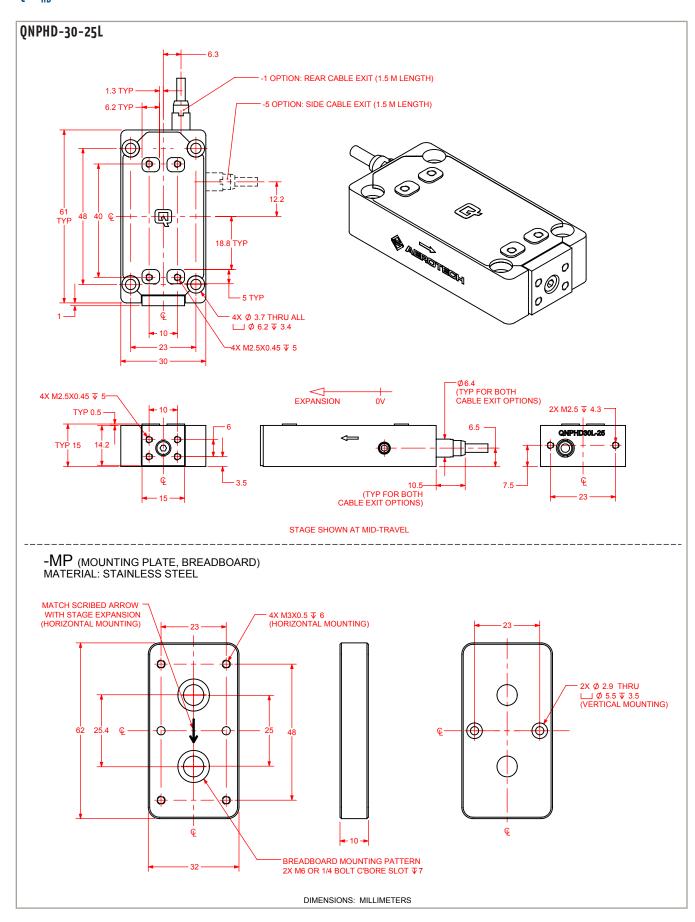
Recommended Controller	
Ensemble	Ensemble QLAB Ensemble QDe Ensemble QLe Ensemble QL
A3200	Ndrive QLe Ndrive QL

<sup>1.</sup> Unless noted, the QLAB, QDe, or QLe drives are required to achieve the listed specifications. Contact Aerotech for specifications when used with the QL drives.

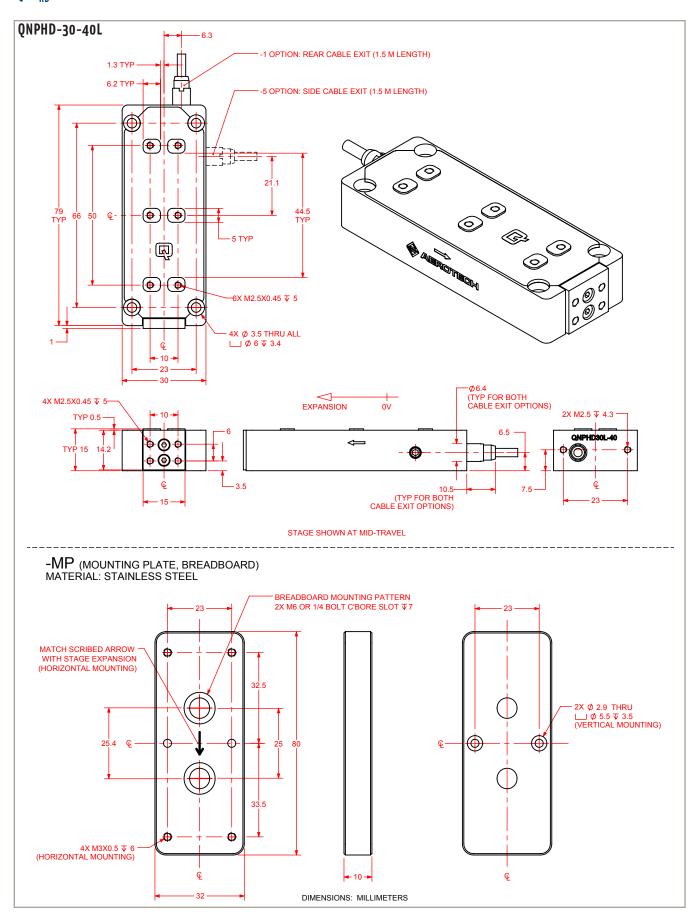
## **QNP<sub>HD</sub> Series DIMENSIONS**



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## $QNP_{HD}$ Series ORDERING INFORMATION

# QNPHD30L Single-Axis, High-Dynamic Piezo Nanopositioning Stages

Travel (	(Required)

-10	10 μm closed-loop travel, 12 μm open-loop travel
-25	25 μm closed-loop travel, 32 μm open-loop travel
-40	40 μm closed-loop travel, 50 μm open-loop travel
Feedback (Optional)	
-C	Capacitance sensor feedback
Cable Exit (Required)	
-1	Rear cable exit
-5	Left side cable exit
Mounting Plate (Optional)	

### Integration (Required)

-MP

Aerotech offers both standard and custom integration services to help you get your system fully operational as quickly as possible. The following standard integration options are available for this system. Please consult Aerotech if you are unsure what level of integration is required, or if you desire custom integration support with your system.

Mounting plate for English and metric optical breadboard tables

-TAS	Integration - Test as system  Testing, integration, and documentation of a group of components as a complete system that will be used together (ex: drive, controller, and stage). This includes parameter file generation, system tuning, and documentation of the system configuration.
-TAC	Integration - Test as components  Testing and integration of individual items as discrete components that ship together. This is typically used for spare parts, replacement parts, or items that will not be used together. These components may or may not be part of a larger system.



Rear mounting holes and side cable exit option allow for easy vertical mounting